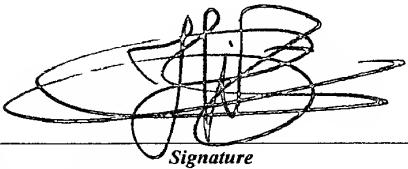


<p style="text-align: center;">O I P E U S P T O M A R K</p> <p>SEP 19 2001</p> <p>TRANSMITTAL LETTER (General - Patent Pending)</p>		Docket No. 11675.114
In Re Application Of: Kei-Yu Ko		
Serial No. 08/846,671	Filing Date April 30, 1997	Examiner George A. Goudreau
Title: UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE		
<i>RECEIVED</i> TO THE ASSISTANT COMMISSIONER FOR PATENTS: SEP 20 2001 TC 1700		
<p>Transmitted herewith is:</p> <p>Transmittal Letter (1 pg. in dup.); Transmittal Letter for Amendment and Response (1 pg.); Amendment D and Response (37 pgs.); Certificate of Express Mailing EL893521051US; Postcard</p> <p>in the above identified application.</p> <p> <input checked="" type="checkbox"/> No additional fee is required. <input type="checkbox"/> A check in the amount of _____ is attached. <input checked="" type="checkbox"/> The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 23-3178 as described below. A duplicate copy of this sheet is enclosed. </p> <p> <input type="checkbox"/> Charge the amount of _____ <input checked="" type="checkbox"/> Credit any overpayment. <input checked="" type="checkbox"/> Charge any additional fee required. </p>  <p><i>Signature</i></p>		
<p>Dated: September 19, 2001</p> <p>Jesus Juanos i Timoneda, Ph.D. Attorney for Applicant Reg. No. 43,332</p> <p> 022901</p> <p>PATENT TRADEMARK OFFICE</p>		
<p>I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.</p> <p><i>Signature of Person Mailing Correspondence</i></p> <p><i>Typed or Printed Name of Person Mailing Correspondence</i></p>		

09-21-01

1763

CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)

Applicant(s): Kei-Yu Ko

Docket No.

11675.114

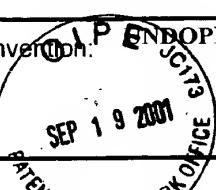
Serial No.
08/846,671

Filing Date
April 30, 1997

Examiner
George A. Goudreau

Group Art Unit
1763

Invention: DOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE



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